



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Patent Application of:		Group Art Unit: 2811	
	Osamu Goto, et al.) Examiner: Ori Nadav	
Application No. 10/606,176)		I hereby certify that this document is being deposite	deposited
Filed:	June 25, 2003	with the United States Postal Service as first in an envelope addressed to: MAIL STO Commissioner for Patents, P.O. Box 1450, A	class mail OP RCE,
For:	SEMICONDUCTOR LIGHT EMITTING DEVICE, ITS MANUFACTURING METHOD, SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD	VA 22313-1450 on June 15, 2005. Magna N. Santo	

MAIL STOP RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO MARCH 15, 2005 OFFICE ACTION

Dear Sir:

This Amendment is submitted in response to the Final Office Action mailed March 15, 2005. Applicants respectfully request amendment of the patent application, and reconsideration and allowance of the pending claims.